EEMF5383 - Plasma Technology

**EEMF 5383 (MECH 5383 and MSEN 5383 and PHYS 5383)** Plasma Technology (3 semester credit hours)
Hardware oriented study of useful laboratory plasmas. Topics will include vacuum technology, gas kinetic theory, basic plasma theory and an introduction to the uses of plasmas in various industries. (3-0) T